# Monthly LabAdviser update: 11/3 2019

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| Updated Subject | Contributor | Link to the updated pages |
| **ASE etch rates**  Nitride eth rate for recipe 1SiO2\_03 | **Karen Birkelund @Nanolab** | [SiO2\_etch\_using\_ASE#The\_recommended\_recipe\_for\_SiO2\_etch\_using\_a\_carrier\_is\_this](http://labadviser.nanolab.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Etching_of_Silicon_Oxide/SiO2_etch_using_ASE#The_recommended_recipe_for_SiO2_etch_using_a_carrier_is_this) |
| **Litho TPT**  Additional training video on the manual spin coaters Labspin02 and 03 incl. what to handle chips | **Lean G. Pedersen @Nanolab** | [Courses#The\_Lithography\_TPT](http://labadviser.nanolab.dtu.dk/index.php/LabAdviser/Courses#The_Lithography_TPT) |
| **Technology Research**  Nanofabrication of Inductive Components for Integrated Power Supply On Chips | **Hoà Lê Thanh @Nanolab** | [LabAdviser/Technology\_Research/Nanofabrication\_of\_Inductive\_Components\_for\_Integrated\_Power\_Supply\_On\_Chip](http://labadviser.nanolab.dtu.dk/index.php/LabAdviser/Technology_Research/Nanofabrication_of_Inductive_Components_for_Integrated_Power_Supply_On_Chip) |

# Equipment Manuals updated in LabManager (since 28th of January):

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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| **Manual for DRIE-Pegasus 1**, ver 3.2 | | |
| **User manual for E-Beam writer JEOL JBX-9500FS**, ver 2.1 | | |
| **Manual for Laser Micromachining Tool**, ver 2 | | |
| **Manual for Lifetime scanner MDPmap**, ver 2 | | |
| **Manual for Optical Profiler (Sensofar)**, ver 3.3 | |
| **Manual for SU-8 Developer Bench**, ver 6 |
| **Manual for Oven 110-250C**, ver 3.1 |
| **Manual for Oven 90C**, ver 3.1 |
| **Manual for Developer TMAH UV-lithography**, ver 3 |
| **Manual for Aligner: MA6 - 2**, ver 2 |
| **Manual for Spin dryer**, ver 1.2 |
| **Manual for Imprinter 1**, ver 3 |
| **Manual for Imprinter 2**, ver 2 |
| **Manual for Critical Point Dryer**, ver 6 |
| **Manual for Isotropic Etch/Poly Etch**, ver 4 |
| **Manual for box washer (washing machine)**, ver 2 |
| **Manual for RCA clean of black silicon**, ver 2 |
| **Manual for Piranha**, ver 2 |
| **Manual for Phosphorus Predep furnace (A4)**, ver 7 |
| **Manual for Apox furnace (D1)**, ver 4.1 |
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